

<b>Notice of References Cited</b>	Application/Control No. 10/539,875		Applicant(s)/Patent Under Reexamination PERRET ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0042027 A1	04-2002	Chou et al.	430/322
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
1	U	Sun et al. Journal of Vacuum Science Technology, B1696), Nov/Dec 1998, pages 3922-3925			
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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